


<b>Search Notes</b> 	<b>Application/Control No.</b> 10784761	<b>Applicant(s)/Patent Under Reexamination</b> MIYAMOTO, ISSHIN
	<b>Examiner</b> Pervan, Michael	<b>Art Unit</b> 2629

SEARCHED			
Class	Subclass	Date	Examiner
345	169	12/21/2006	MP
above	updated	7/6/2007	MP
345	170-178	7/6/2007	MP

SEARCH NOTES		
Search Notes	Date	Examiner
see attached EAST search results	12/21/2006	MP
class 345 and text search	12/21/2006	MP
class 379 and text search	12/21/2006	MP
see attached updated EAST search results	7/6/2007	MP
Interference search: ((pressure near5 sensitive near5 resistor) and ((press touch) near5 simultaneous)).clm.	7/6/2007	MP

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner
345	169-178	7/6/2007	MP